

Docket No. 198322US-2 CONT

IN RE APPLICATION OF: TAKAHIRO HORIKOSHI ET AL.

SERIAL NO: 09/680,513

RCE FILED: MAY 3, 2002

FOR: EXPOSURE METHOD, EXPOSURE APPARATUS...



ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

RECEIVED
NOV 21 2002
TECHNOLOGY CENTER 2800

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☒ Additional documents filed herewith: Marked-Up Copy of Amendment, Request for Extension of Time

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS	
TOTAL	64	MINUS	58	6	× \$18 =	\$108.00	
INDEPENDENT	11	MINUS	12	0	× \$84 =	\$0.00	
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00	
		TOTAL OF ABOVE CALCULATIONS					\$108.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity					\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00	
		TOTAL					\$108.00

- ☒ A check in the amount of **\$1,028.00** is attached.
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Gregory J. Maier
Registration No. 25,599

Surinder Sachar
Registration No. 34,423



22850

Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 10/00)

198322US-2 CONT



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
TAKAHIRO HORIKOSHI ET AL. : GROUP ART UNIT: 2851
SERIAL NO: 09/680,513 :
RCE FILED: MAY 3, 2002 : EXAMINER: BROWN, K.
FOR: EXPOSURE METHOD, EXPOSURE
APPARATUS AND MAKING METHOD
OF THE APPARATUS, AND DEVICE
AND MANUFACTURING METHOD
OF THE DEVICE

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action of May 17, 2002, please amend the above-identified application as follows:

IN THE CLAIMS

Please cancel Claims 22 and 53 without prejudice.

Please amend Claims 1, 4-6, 14, 16, 23, 24, 42, and 46 to read as follows:¹

1. (Thrice Amended) An exposure method to transfer a pattern of a mask illuminated with exposure light from a light source onto a substrate through an optical system, said method comprising:
- setting a time interval for measurement of a transmittance of said optical system;

¹A marked-up copy of the amendments is attached hereto.

#21/C
11-25-02
gfr
RECEIVED
NOV 21 2002
TECHNOLOGY CENTER 2800

11/19/2002 SSESHE1 00000045 09600513

108.00 DP

01 FC:1202